

FORM PTO-1449	SERIAL NO. 10/519,223	CASE NO. 11336/788
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	FILING DATE November 21, 2005	GROUP ART UNIT 2628 CONF. NO. 9718
(use several sheets if necessary)	APPLICANT(S): Marek Strassenburg-Kleciak	

REFERENCE DESIGNATION
U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER <small>Number-Kind Code (if known)</small>	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
/W.S./	B1	5,566,073	10/15/1996	Margolin	364/449	08/09/1995
	B2	5,988,862	11/23/1999	Kacyra et al.	364/578	04/24/1996
	B3	6,246,468 B1	06/12/2001	Dimsdale	365/4.02	10/23/1998
	B4	6,600,553 B1	07/29/2003	Stone	356/4.01	10/21/1999
	B5	2001/0056308 A1	12/27/2001	Petrov et al.	700/98	03/28/2001
	B6	2006/0110026 A1	05/25/2006	Strassenburg-Kleciak et al.	382/154	06/30/2003
/W.S./	B7	2006/0188143 A1	08/24/2006	Strassenburg-Kleciak	382/154	11/21/2005

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER <small>Number-Kind Code (if known)</small>	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES OR NO
/W.S./	B8	DE 199 48 544 A1	05/10/2001	GERMANY	G01C 11/10	Abstract only
/W.S./	B9	WO 01/31290 A2	05/03/2001	WIPO	G01B 11/00	In English

**EXAMINER
INITIAL**
OTHER ART - NON PATENT LITERATURE DOCUMENTS

(Include name of author, title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.

/W.S./	B10	Nakagawa, M., Shibasaki, R., "Study on Making City Model with Image and Laser Range Data," 22nd Asian Conference on Remote Sensing, 5-9 November 2001, Singapore. © 2001 Centre for Remote Imaging, Sensing and Processing (CRISP), National University of Singapore; Singapore Institute of Surveyors and Valuers (SISV); Asian Association on Remote Sensing (AARS).				

EXAMINER /Wesner Sajous/	DATE CONSIDERED 01/28/2008
--------------------------	----------------------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.